

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	((substrate or wafer) and (first adj polysilicon) and (second adj polysilicon) and (gate adj (insulat\$3 or dielectric)) and (first adj gate) and (second adj gate) and (dop\$3 or implant\$3) and (first adj type) and (second adj type) and ((heavily adj doped) or source or drain) and (lightly adj doped)).CLM.	US-PGPUB	OR	ON	2006/03/14 17:05